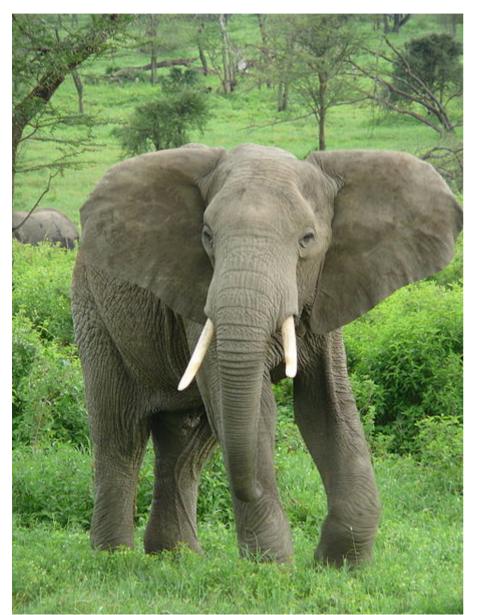
# Instrumentation Requirements for Different Accelerator Types

Bernhard Holzer, CERN

## Instrumentation Requirements for Different Accelerator Types

#### Bernhard Holzer, CERN



high energy proton machines

LHC, Tevatron, HERA, RHIC

synchrotron light sources

ESRF, PETRA 3, SLS ...

therapy machines

HIT, Proscan ...

sase FEL's

ILC / CLIC

... cyclotrons, betatrons, proton linacs el. static machines, heavy ion storage rings ...



# I. (s.c.) High Energy Proton Machines

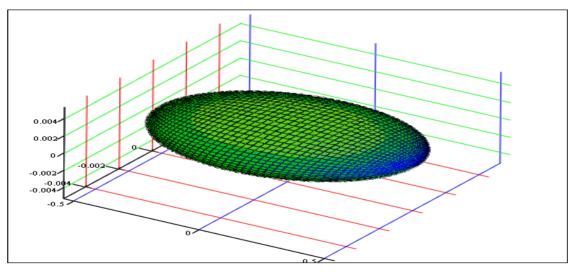
#### LHC parameters

7 TeV proton energy particles per bunch 1.2\*10 11 number of bunches 2808 0.582 Abeam current 362 MJ stored beam energy  $\approx 8 cm$ bunch length beam size (arc)

1.2mm ... 0.3 mm

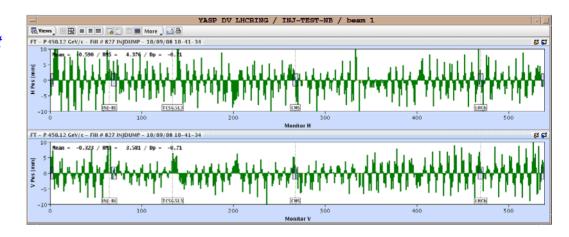


**SPS & LHC at CERN** 

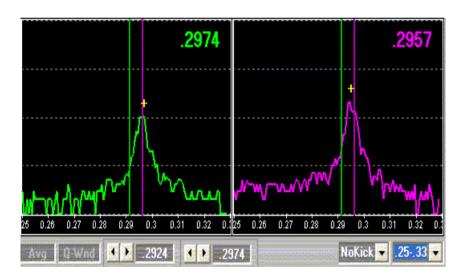


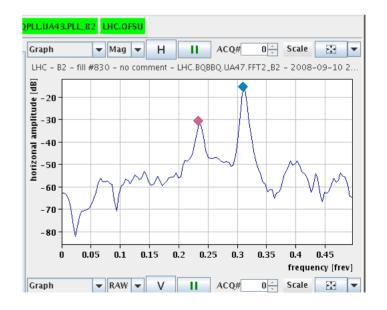
## beam parameters ... the standards

orbit



#### tune, chromaticity, coupling



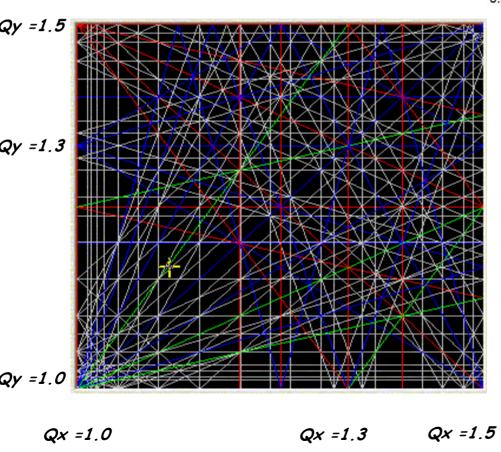


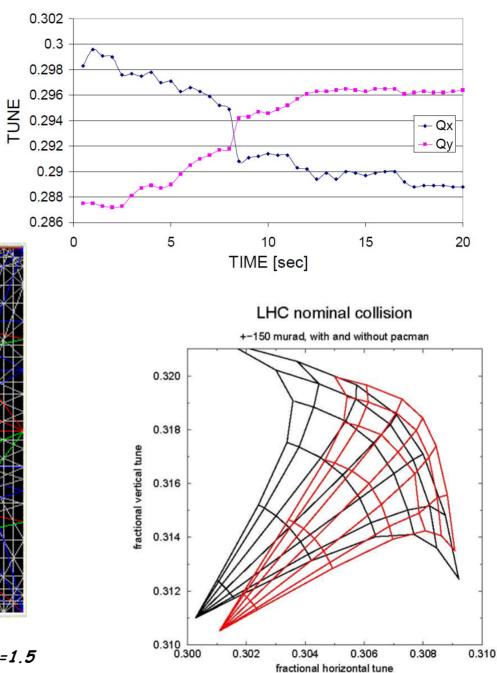
the non standards: keep these values constant during ramp "snapback"

## Tune and Resonances

$$m*Q_x+n*Q_y+I*Q_s = integer$$

# HERA p Tune diagram up to 7th order





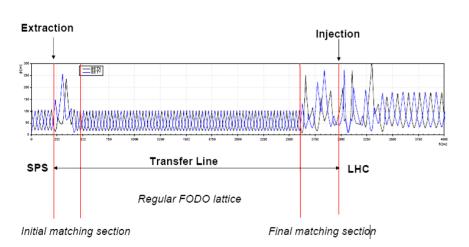
#### Beam Emittance

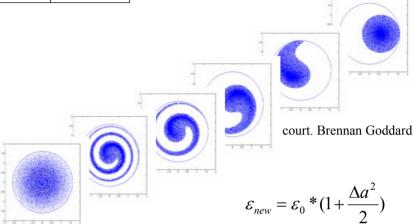
	E <sub>k</sub> [GeV]	ε* [π μm]	σ [mm]
LINAC	0.0001 - 0.05	~1.0	
BOOSTER	0.05 - 1.4	2.5	0.3 - 6.5
PS	1.4 - 26	3.0	0.3 - 15
SPS	26 - 450	3.5	0.1 - 6
LHC	450 - 7000	3.7	0.1 - 2

tight emittance budget for beam transfer & accleration

measure: position & angle at injection optics mismatch between transfer lines and storage ring

SPS to LHC transfer line TI 8 – beta functions

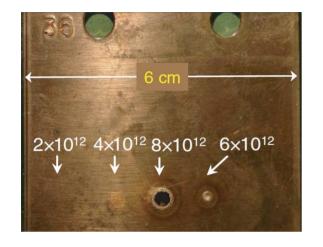




emittance dilution due to offset at injection

... (OTR) screens, wire scanners, residual gas monitors etc

#### minor detail: beam energy = 360 MJ



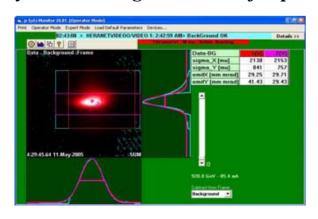


OTR & scintilltion screens at ELETTRA (Trieste) DIPAC 2007

beam dump tests of a 450 GeV SPS beam on a target

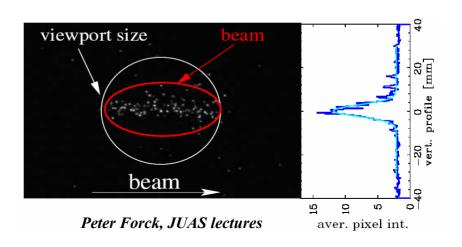
#### possible solutions: don't touch

#### synchrotron light monitors for proton beams

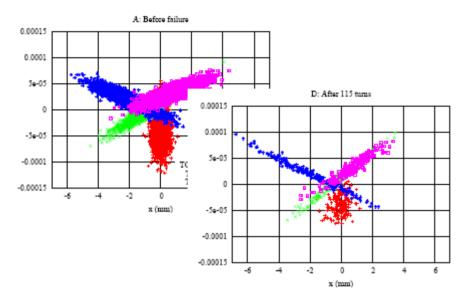


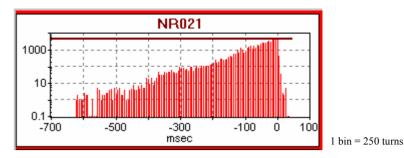
Gero Kube, CAS lectures 2008

#### residual gas monitors



## Machine safety: Detection of Beam Losses





beam losses in HERA -p seen by a single BLM failure of standard magnet (dipole /quadrupole)

A. Gomez: Error analysis in LHC, Phase space deformation in case of failure of RQ4.LR7

#### Short Summary of the studies:

quench in sc. arc dipoles:  $\tau_{loss} = 20 - 30 \text{ ms}$ 

BLM system reacts in time, QPS is not fast enough

quench in sc. arc quadrupoles:  $\tau_{loss}$ =200 ms

BLM & QPS react in time

failure of nc. quadrupoles:  $\tau_{det}$ 

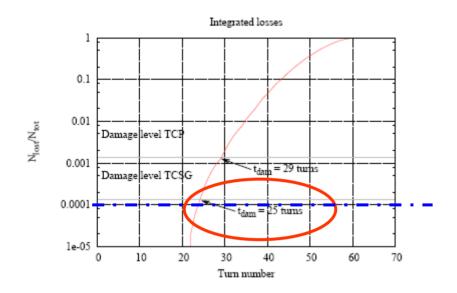
 $\tau_{damage} = 6.4 \text{ ms}$ 

→ FMCM installed

failure of nc. dipole:

 $\tau_{damage} = 2 \ ms$ 

## Analysis of fast beam losses (A. Gómez)



worst case: nc. dipole magnets: RD1.LR1/LR5
simulaion of beam losses due to failure of RD1
damage level reached after 25 turns

 $\tau_{BLM \ react.} \approx \tau_{damage}$ 

FMCM installed (M. Werner et al)
... but redundancy does not really exist

... does it make sense to contemplate about a fast AC beam current monitor in LHC???
(M. Werner et al)

experience is excellent: combination of fast FMCM and AC-BM installed at HERA in 2003/2004

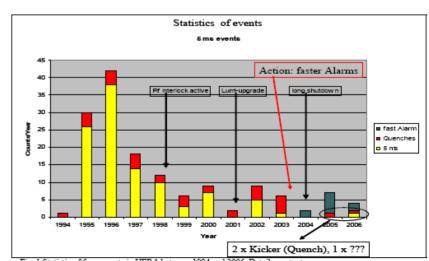
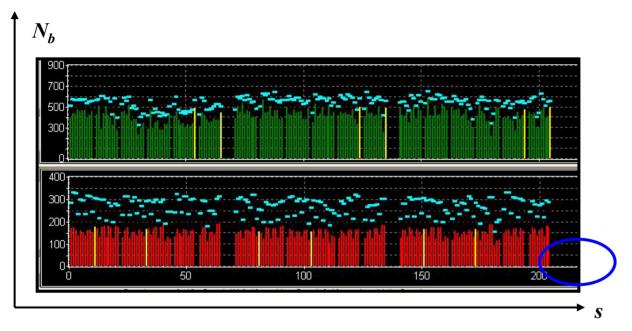
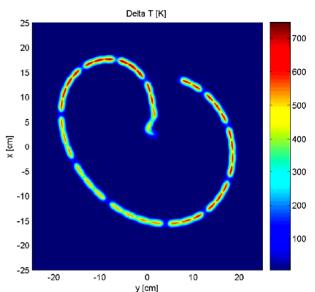


Fig. 1 Statistic of 5 ms events in HERA between 1994 and 2006. Details see text

## **Dump-Gap Monitoring:** AC/DC Monitors





pattern of the LHC bunch train at the dump absorber screen

#### HERA Bunch Pattern:

 $C_0 = 6335m$ 

nb = 180

bunch distance = 96 ns

#### LHC parameters:

 $C_0 = 26660 \ m$ 

nb = 2808

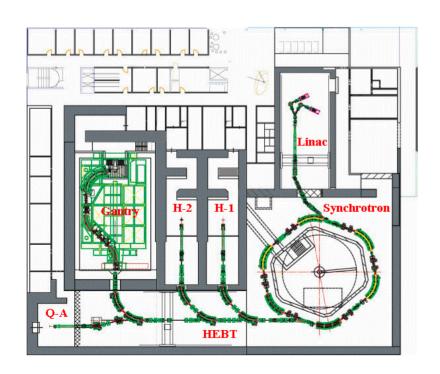
bunch distance = 25 ns!!!

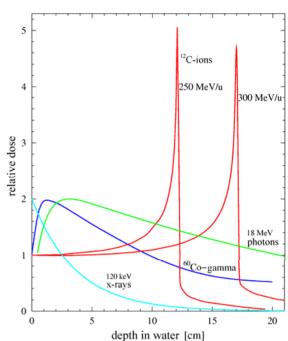
LHC abort gap:  $3\mu s \approx 900m$ Quench limit for gap population at 7 TeV:  $2*10^6$  p/m or  $5*10^{-6}$  of overall current or  $3.2 \mu A$  DC

## II. Hadron Therapy Machines

the standards: beam energy, intensity, tunes, orbits not really a problem

#### **Example: parameters of the HIT project in Heidelberg:**





control of penetration depth / Bragg peak via beam energy

particles: p, C, He, O

beam energy 50 - 430 MeV/u

beam size 4-10 mm extraction time 1-10 s

extraction intensity  $10^6$  -  $4*10^{10}$  ions / spill

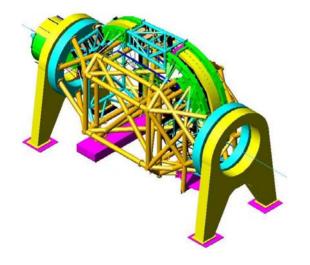
beam power 360 W dc power

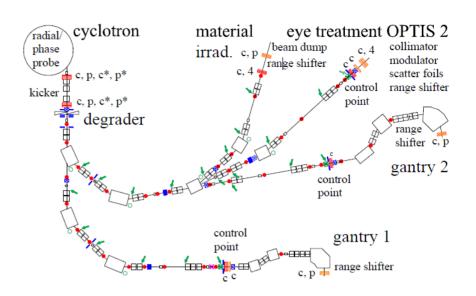
## The challenge: Stability

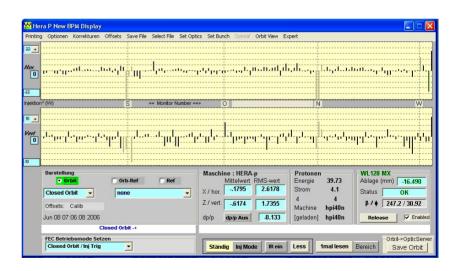
#### Example: PSI proscan project

- 37 multistrip ionisation chambers
- 5 faraday cups
- 6 thin current monitors
- 4 bpms
- 22 halo monitors
- 7 extr. loss monitors

#### gantry: 3 dipoles 8 quads ... all in all 570 t



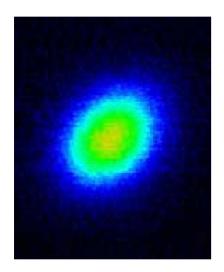




so sorry: Example how not to do it the old & rusty HERA-p BPM system

## The Challenge: Slow Extraction

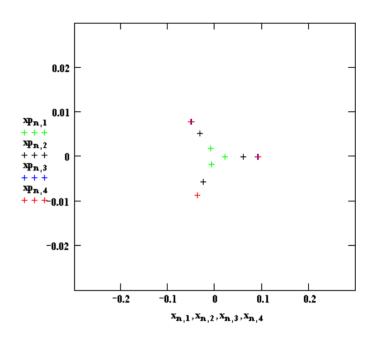
3 order resonance extraction dedicated & well controlled excitation of the beam be conservativ, ... & ... stable aim: constant spill intensity

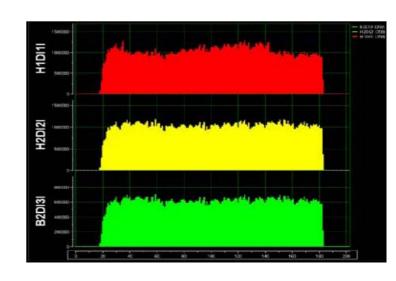


transverse beam profile

$$\frac{10^{10} \, \mathbf{p}}{10 \, \mathbf{s}} = \frac{10^9 \, *1.6 \, *10^{-19} \, \mathbf{Cb}}{\mathbf{s}} = 1.6 \, *10^{-10} \, \mathbf{A}$$

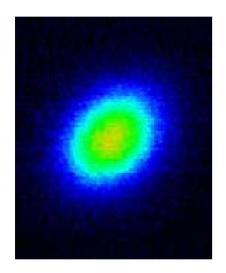
spill intensity diagnostics: 1% accuracy non destructive measurement of fraction of nA in single pass!!! keyword: secondary emission monitors





## The challenge: Slow Extraction

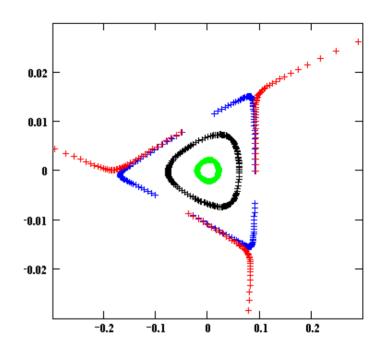
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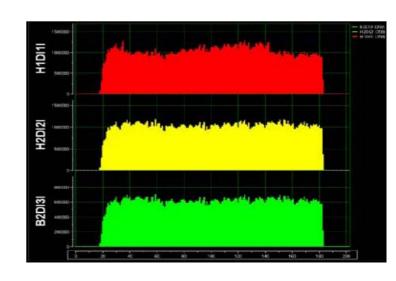


transverse beam profile

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spill intensity diagnostics: 1% accuracy non destructive measurement of fraction of nA in single pass !!! keyword: secondary emission monitors





## III. Light Sources

The Standards: beam energy, intensity, tunes etc ... not really a problem

BUT measurement & control of beam size & beam orbits is a real challenge

photon flux 
$$F = \frac{number\ of\ photons}{s*0.1\%BW*A}$$

brilliance 
$$B = \frac{F}{4\pi^2 \varepsilon_x \varepsilon_y}$$

emittanz≈1 nm rad (PETRA 3)

$$\varepsilon_y \approx 1\% \ \varepsilon_x$$

	$\epsilon_x$ [nmrad]	E [GeV]	$\epsilon_x/E^2$		$\epsilon_x$ [nmrad]	E [GeV]	$\epsilon_x/E^2$
USR	0.3	7	0.006	SLS	4.4	2.4	0.763
PETRA III	1	6	0.027	ELETTRA	7	2.4	1.215
SPring-8	3.4	8	0.053	BESSY II	6	1.9	1.66
APS	3	7	0.061	Spear III	18	3	2
ESRF	3.9	6	0.108	MAX II	9	1.5	4
Diamond	2.5	3	0.2	ANKA	41	2.5	6.56
Soleil	3	2.5	0.48	DORIS III	450	4.5	22.2

Parameters of some synchrotron light sources

HERA/LEP Emittance: 20 ... 30 nm

## **Light Sources**

#### requirements for orbit stability: golden rule $\approx 10\% \sigma$

 $\rightarrow$  orbit measurement resolution:  $\leq 1 \mu m$ 

PETRA 3: 220 button BPMs installed, BPM resolution ≈ 0.3 µm required

	$\beta_{x}$	$\beta_y$	$\sigma_{Tx}$	$\sigma_{Ty}$	$\sigma_{Tx'}$	$\sigma_{Ty'}$	ID-length
	[m]	[m]	$[\mu m]$	$[\mu m]$	[ $\mu$ rad]	[ $\mu$ rad]	[m]
low-β 5 m	1.3	3	36	6.0	28	3.7	5
high- $\beta$ 5 m	20	2.4	141	5.5	7.7	3.8	5
$low-\beta 2\times 2 m$	1.4	3	37	5.7	27	5.4	2
high- $\beta 2 \times 2 \mathrm{m}$	16.2	2.6	127	5.3	9.3	5.5	2
20 m-ID	16	5	126	7.9	8.2	2.7	10
DW-drift	16	16	127	13	8.5	3.3	5
ESRF low- $\beta$	0.5	2.73	59	8.3	90	3	5
ESRF high- $\beta$	35.2	2.52	402	7.9	10.7	3.2	5
SPring-8	22.6	5.6	277	6.4	13	5	4.5
APS	15.9	5.3	217	12.6	15.3	5.7	4

typical beam sizes

orbit stability required for stable light fan
due to offset in 6poles / quads → spurious vert. dispersion,
coupling → spoils vert. beam emittance

By the way: diagnostic and control of temperature coefficient of thermal expansion in steel: 12 \*10-6

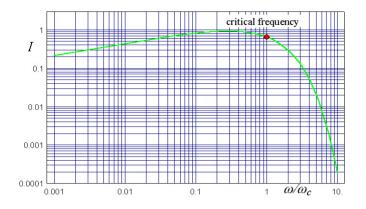
$$\Delta l = 10cm * 12 * 10^{-6} * 1^{\circ}$$

$$\Delta l = 1.2 \mu m \text{ for } \Delta T = 1 \text{ degree}$$

$$d = 1.2 \mu m \text{ for } \Delta T = 1 \text{ degree}$$

$$d = 1.2 \mu m \text{ for } \Delta T = 1 \text{ degree}$$

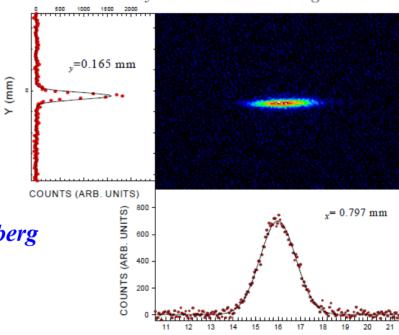
## The ideal Diagnostics Tool: ... Sy-Li



1.5 GeV,  $\rho = 3.3m$ 

#### Result from synchrotron light monitor

Synchrotron radiation facility APS accumulator ring and blue wavelength:



## ... and its principle limitation: Werner Heisenberg

diffraction limit ... mainly in vertical plane

$$\Delta \sigma = \lambda/2\Delta \Psi$$

Example: 1 GeV electron beam

 $\lambda$ =500 nm = green-blue

 $\Delta \psi = 1/\gamma$ , opening angle of light cone

relativistic factor:  $\gamma = E/E_{\theta}$ , E=1 GeV

completely diffraction limited measurement

$$\Delta \sigma = \frac{\lambda}{2\Delta w} = \frac{500 nm}{2*0.5 mrad} = 500 \mu m$$

pinhole cameras interferometric techniques

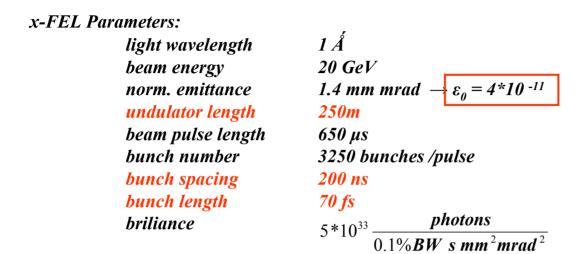
X (mm)

### III. Sase-FEL's

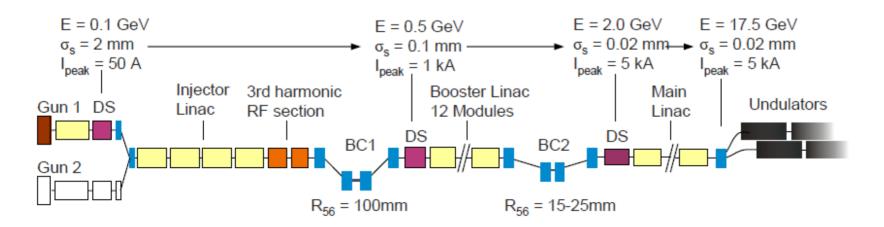
#### Standards: there are no standards

nota bene: HERA / LEP

 $\varepsilon_0 = 20 \dots 30 \text{ nm}$ 



#### schematic view of the europ. x-FEL



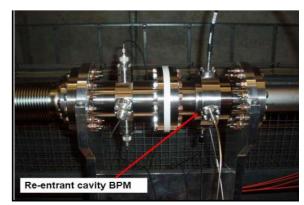
### Sase-FEL's: diagnostic requirements

non-destructive single event (i.e. single pass) diagnostics needed no periodicity, no averaging over several turns, not even over several bunches. intra-bunch-train feedback (IBTF)  $\rightarrow$  sub  $\mu$ s diagnostics beam size (undulator)  $\sigma \approx 30~\mu$ m RMS position stability  $\approx 10\%$  of the beam size  $\sigma$  in the undulators single bunch orbit resolution  $\approx 1~\mu$  m over undulator length (250 m) machine safety: average beam power 600kW in Strahl

Transv. IBFB Specifications	FLASH	XFEL
bunch-by-bunch stability - at location of IBFB - along undulators	< σ/10 5 - 15 μm < 5 μm	< σ/10 3 - 10 μm < 3 μm
max. beam position offset - at location of the pick-ups	< 10 · σ < 1.5 mm	< 10 · σ < 1 mm
bunch-by-bunch resolution	≤ 2 µm	≤ 1 µm
system latency	< 1000 ns	< 200 ns

**Keywords:** Resonant Stripline BPMs

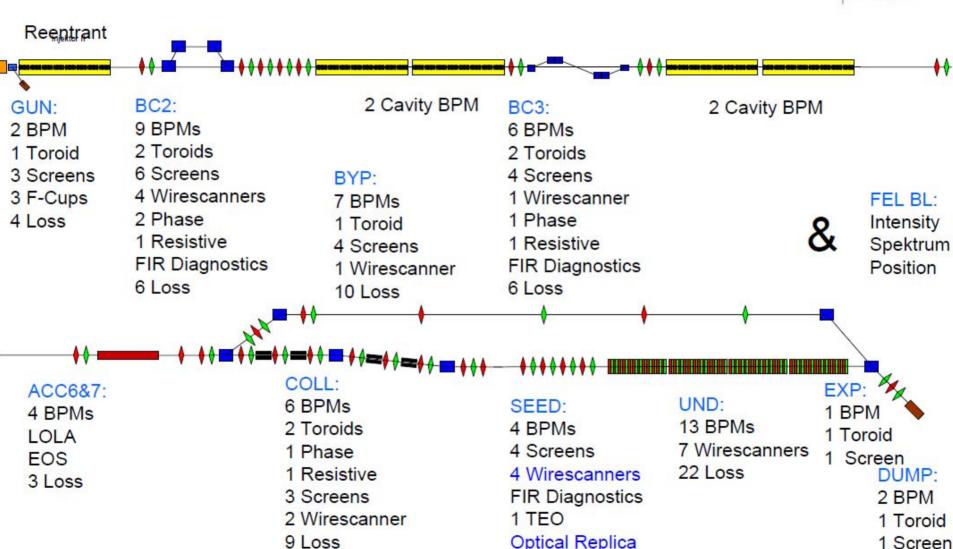
BPM's as reentrant cavity design



# FEL Diagnostics @ FLASH



4 Loss



courtesy: D. Nölle (DESY)

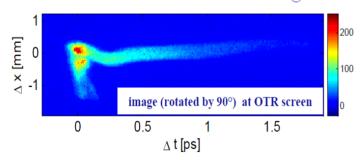
## Sase-FEL's: diagnostic requirements

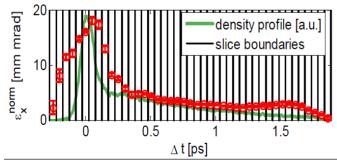
special problem: slice emittance
development of micro bunches

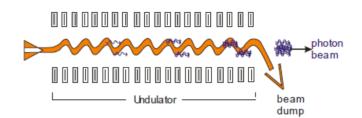
norm. emittance  $\varepsilon_0 = 1.4$  mm mrad  $\rightarrow \varepsilon_0 = 4*10^{-11}$ 

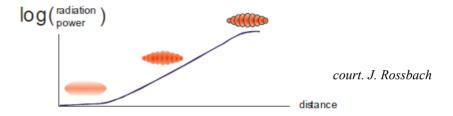
# **Keyword:** Transverse Deflecting RF-Structure "LOLA"

FLASH: slice emittance under SASE conditions @ 13.7 nm









court. H. Schlarb

# International Linear Collider court. G. Kube, CAS 2008

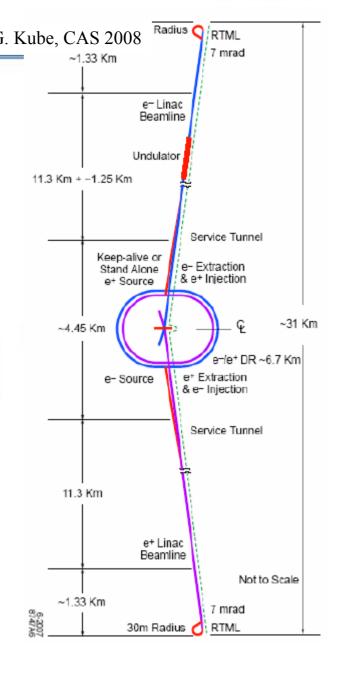
key parameters (nominal values)

train repetition rate / Hz	5
bunches per train	2625
bunch spacing / nsec	369.2
train length / μsec	~ 970
particles per bunch / x 10 <sup>10</sup>	2
normalized emittance at IP γε <sub>x,y</sub> / mm mrad	10 / 0.04
r.m.s. beam size at IP σ <sub>x,y</sub> / nm	639 / 5.7
r.m.s. bunch length $\sigma_z$ / $\mu m$	300
power per beam at IP / MW	10.5
Luminosity £ 10 <sup>34</sup> / cm <sup>2</sup> / sec	2

ILC Reference Design Report (2007)

Challenges: beam position measurement beam stability beam size

non-invasive

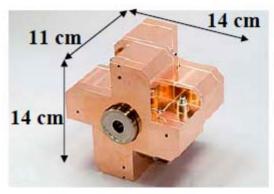


# ILC: Diagnostics con

court. G. Kube, CAS 2008



- beam position measurements with sub-µm resolution
  - Cavity BPMs for higher resolution applications
  - location in cold and warm sections
  - variety of R&D activities for ILC BPMs at different laboratories
  - single bunch position resolution of ~20 nm achieved at ATF (KEK)



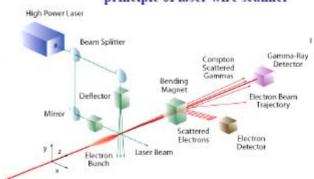
courtesy: T.Nakamura (Tokio University)

high resolution cavity BPM for ILC final focusing system

#### • non-invasive beam profile monitors

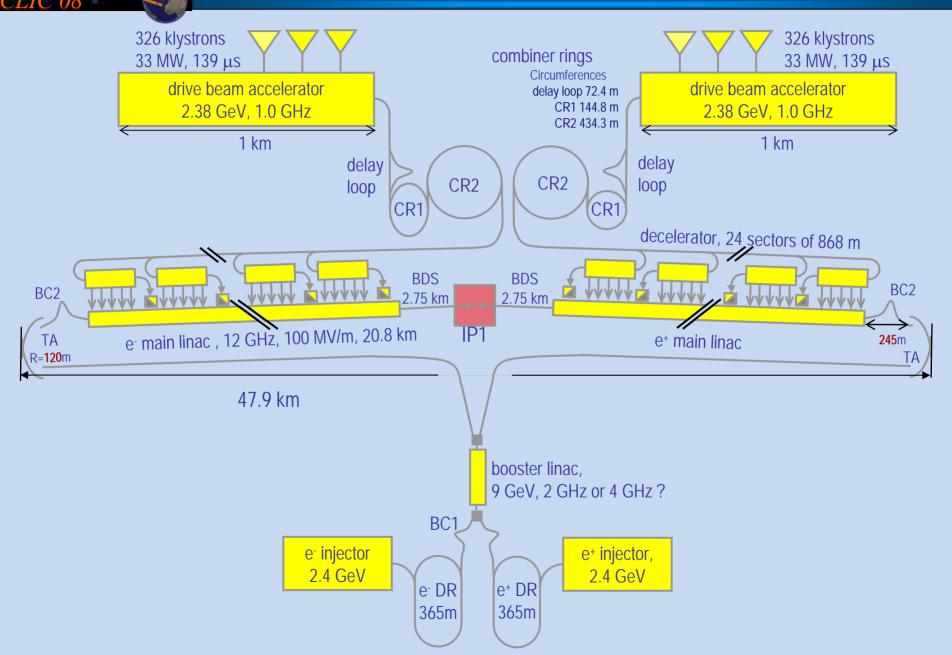
- laser wire scanner
- scanning a finely focussed laser beam across bunches
- · measure Compton scattered photons in downstream detector
- photon rate as function of relative laser beam position
  - → beam profile
- optical diffraction radiation (ODR)
- diffraction of particle Coulomb field at a slit

#### principle of laser wire scanner



ILC Reference Design Report (2007)







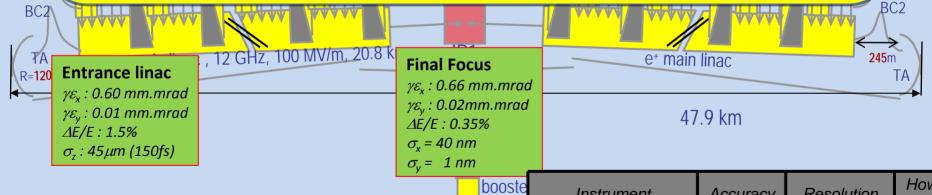




142812

<5um

- Producing and measuring small beam emittance
- Producing and measuring short Bunches
- Conserving small beam emittance (very strict tolerances/requirements on the **beam position monitor precision and resolution**)



BC<sub>1</sub>

e- DR

365m

#### **Damping ring**

 $\gamma \varepsilon_{\rm x}$ : 10 -> 0.381 mm.mrad  $\gamma \varepsilon_{\rm v}$ : 10 -> 0.004 mm.mrad

 $\Delta E/E : 0.134\%$   $\sigma_7 : 1.5mm (5ps)$ 

e<sup>-</sup> injector 2.4 GeV

/	- \
	e+ DR
	IC DI
	\365m
	300111

Wakefield monitor

9 GeV

Accuracy	Resolution	How many
0.1%		48
5µm	50nm	4176
10%	2%	48
0.10%		48
	0.1degree	•
	2%	2
	0.1% 5μm 10%	0.1% 5μm 50nm 10% 2% 0.10% 0.1degree

5um